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Docket No.: 8733.307.00-US  
(PATENT)

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Oh-Nam Kwon

Application No.: 09/709,483

Group Art Unit: 2823

Filed: November 13, 2000

Examiner: Thanh V. Pham

For: **METHOD OF MANUFACTURING A THIN  
FILM TRANSISTOR**

**PRELIMINARY AMENDMENT**

**BOX RCE**

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

**IN THE DRAWINGS:**

Please amend the drawings as shown in red in the Request for Examiner's Approval of Drawing Changes submitted on July 3, 2002.

**IN THE SPECIFICATION:**

Please amend the specification as follows (A Marked-Up Version of the Amended Specification is attached):

On page 2, Paragraph beginning on line 13:

Fig. 1 is a cross sectional view illustrating a typical AM-LCD device. As shown in Fig. 1, the LCD device 20 includes lower and upper substrates 1 and 3, with a liquid crystal layer 10